

Growth of (In,Ga)-(As,P) Nanowires by MOCVD

J.G. Cederberg, A.A. Talin, D.P. Nelson, K.C. Cross, G. Subramania
Sandia National Laboratories

Outline

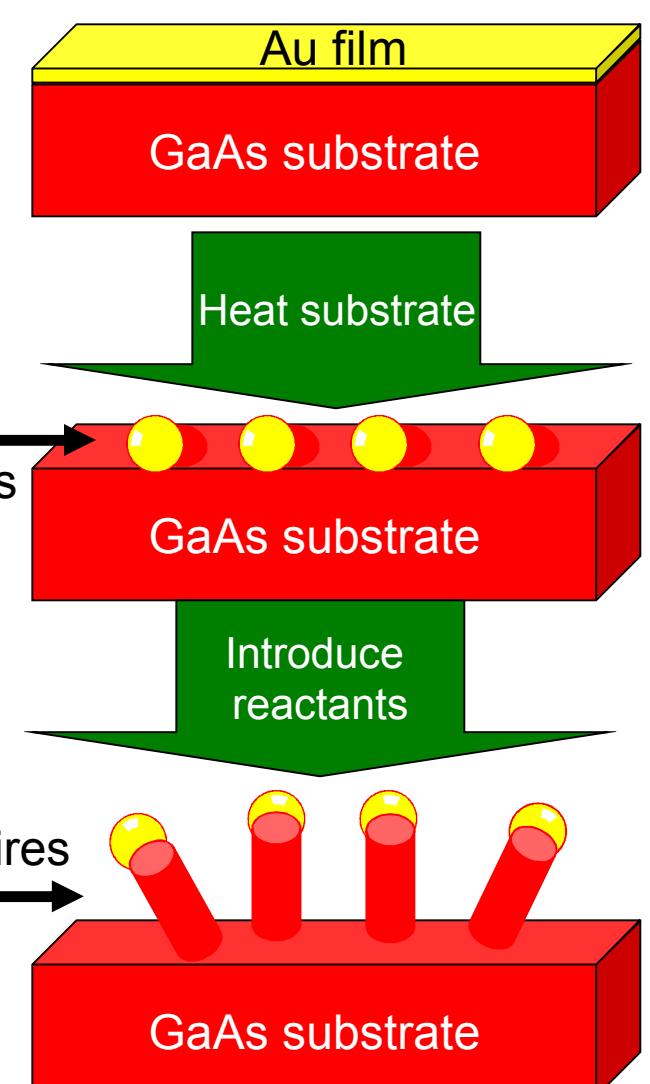
- Motivation
- Process details
- Initial growth demonstration of (In,Ga)-(As,P) nanowires
- Morphology sensitivity of GaAs nanowires
 - Effects of growth temperature and AsH_3 partial pressure
- Nanowire growth model
- Oriented growth of GaAs nanowires
- Controlled size and placement of GaAs nanowires
- Doping issues for (In,Ga)(As,P) nanowires
- Conclusions

Motivation

- Properties of materials modified by reducing dimensions (2D to 1D to 0D)
 - e.g. quantum wells, carbon nanotubes, quantum dots
- New physics and applications may be enabled by nanostructures
 - Photonics
 - Electronics
 - Sensors
- Reduced dimensions could allow integration of dissimilar materials
 - Eliminate defects due to lattice mismatch

Nanowire Growth

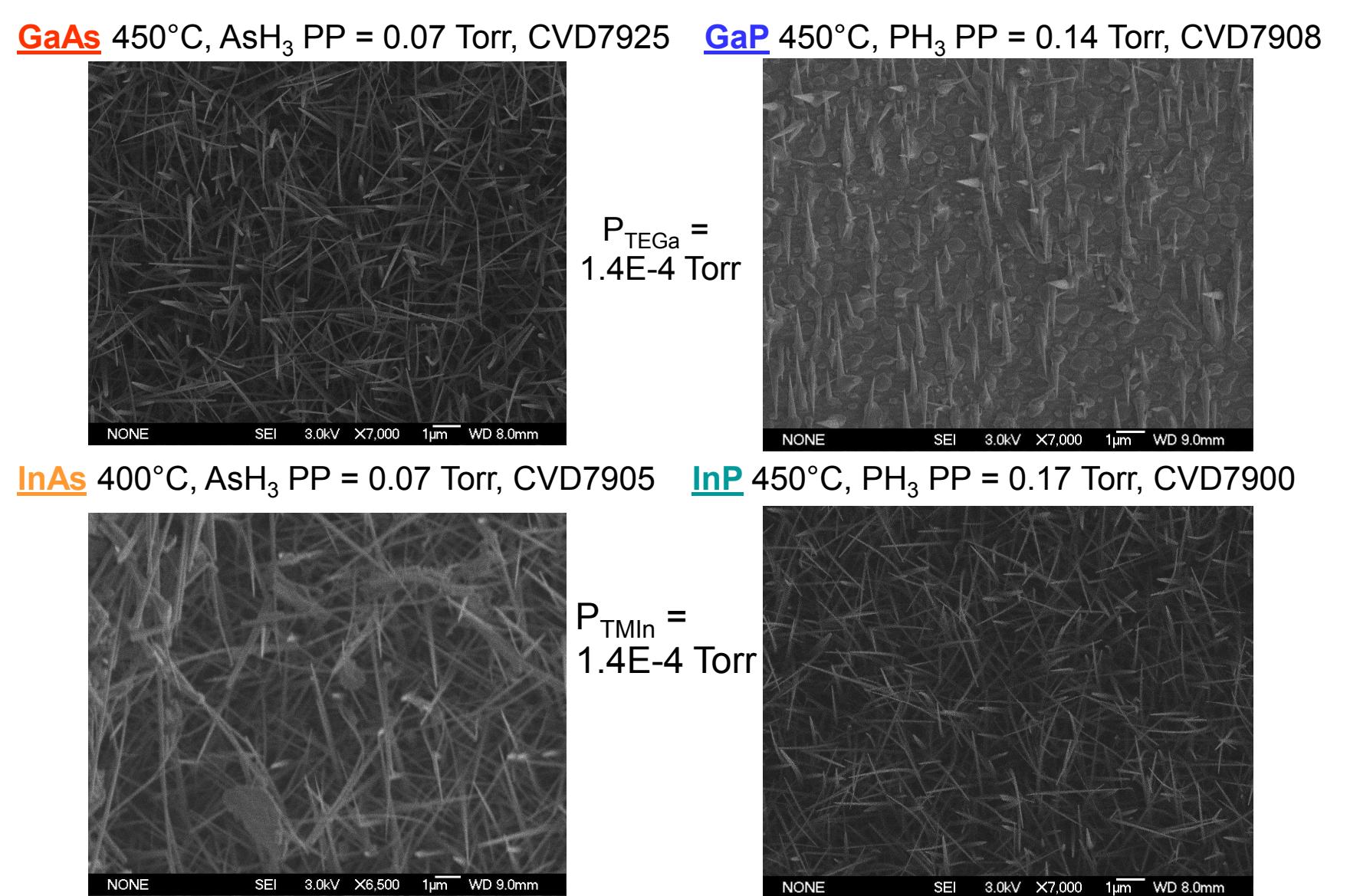
- Use Vapor Liquid Solid(VLS)/Vapor Solid Solid (VSS) technique
 - Use Au as "catalyst" for nanowire growth
 - Dispersed by anneal above growth temperature
- Use metal-organic chemical vapor deposition (MOCVD) to introduce reactants
- Nanowires can propagate normal to many crystal planes



Initial Growth Conditions

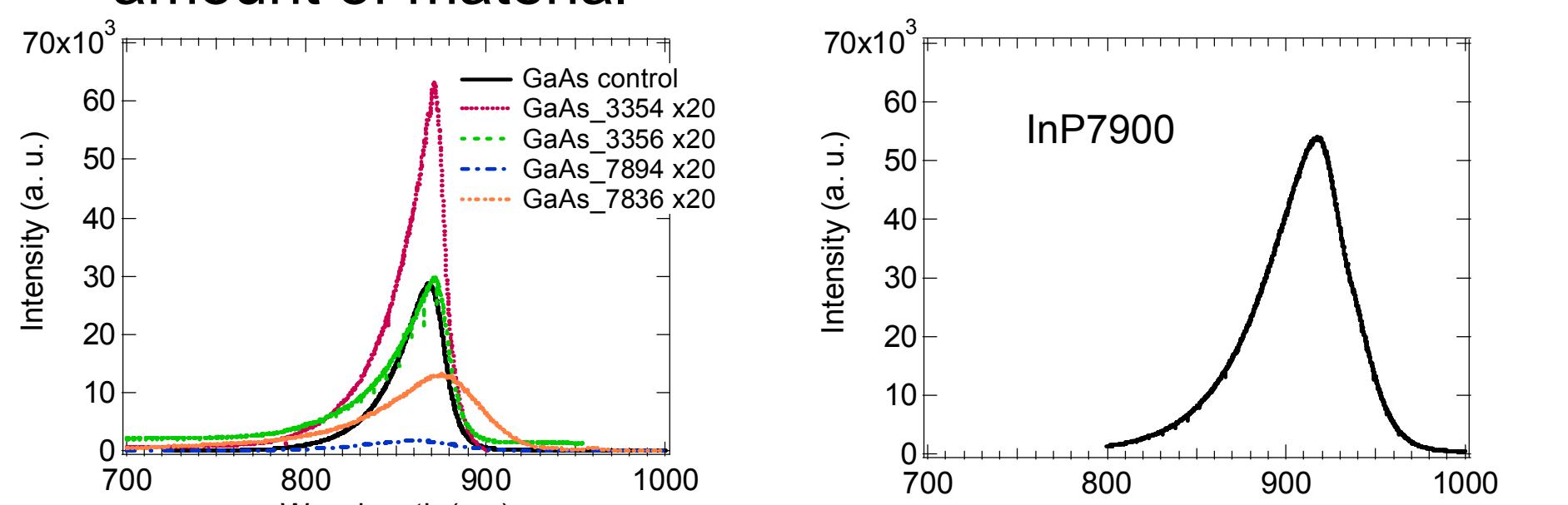
- Growth performed in vertical rotating disk growth chamber held at 70 Torr using H_2 ambient.
- Use GaAs substrates covered with $1 \pm 0.5 \text{ nm}$ of Au
- Au dispersed by heating sample under AsH_3 to 650°C for 10 min
- Cooled to nanowire growth temperature
- Introduced appropriate gases
 - triethylgallium, trimethylindium, arsine, or phosphine
- All samples grown for 50 min

Nanowires growth on GaAs(100)

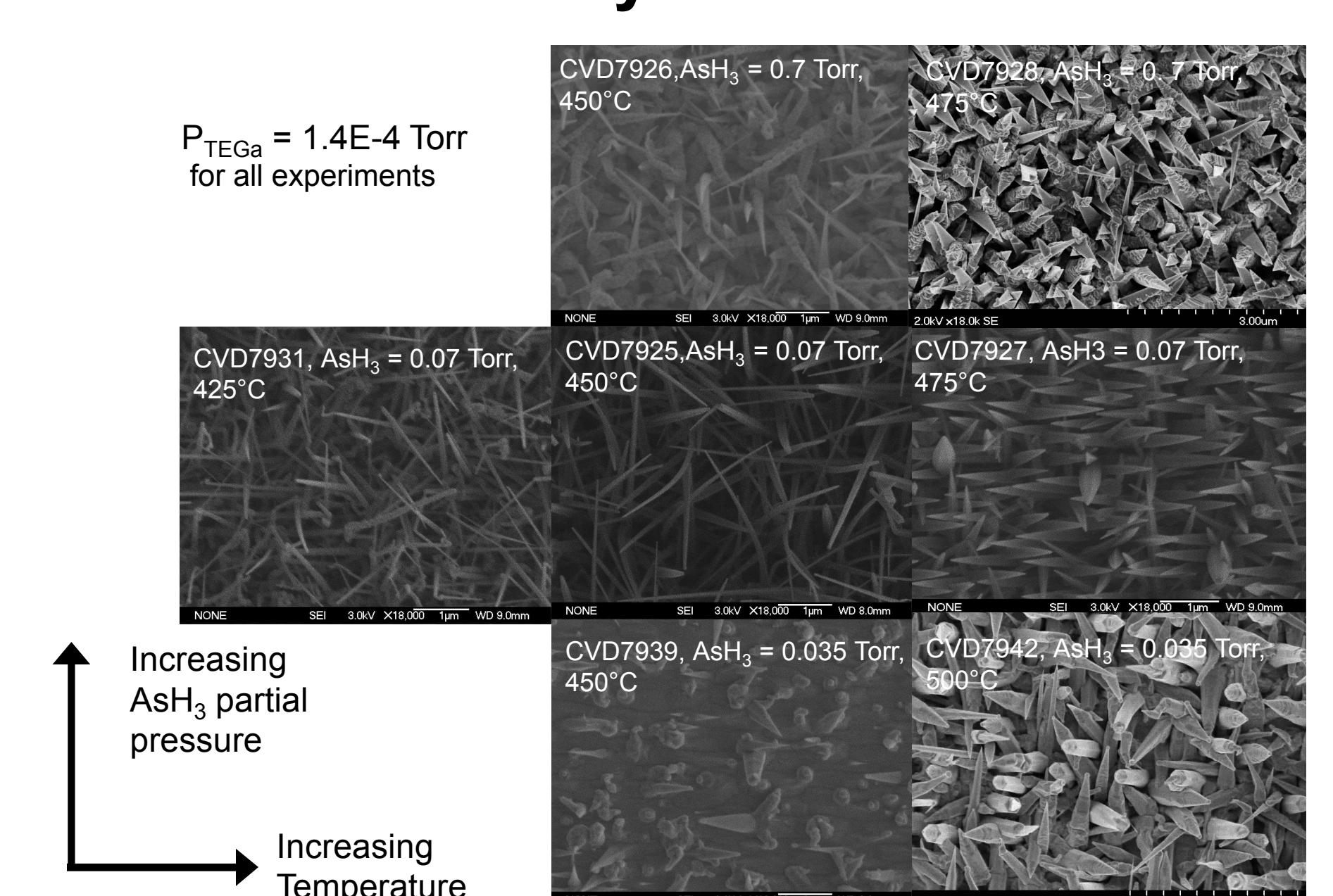


Photoluminescence from GaAs and InP nanowires

- Observed room temperature PL from InP and GaAs nanowires
 - Resonances correspond to bandgap energies for bulk films
 - Suggests nanowires are too large to observe quantum effects
 - FWHM for resonance is broader than for bulk films
 - InP nanowires have 88 meV FWHM, undoped planar InP has 39 meV FWHM
- Small signal from nanowires expected given small amount of material

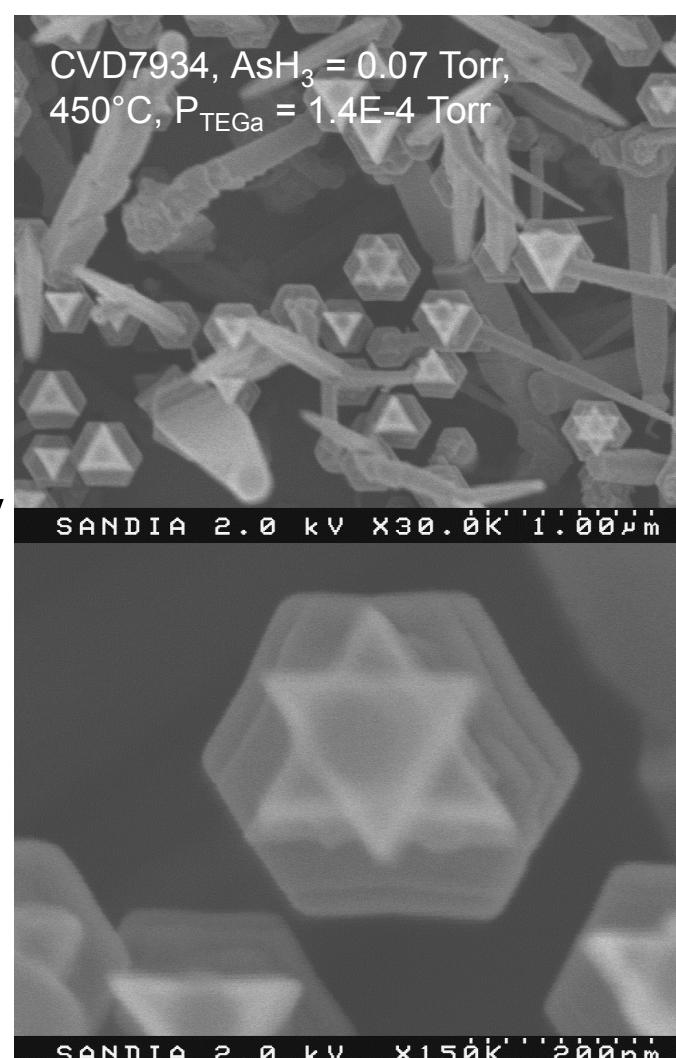


Process Sensitivity for GaAs Nanowires

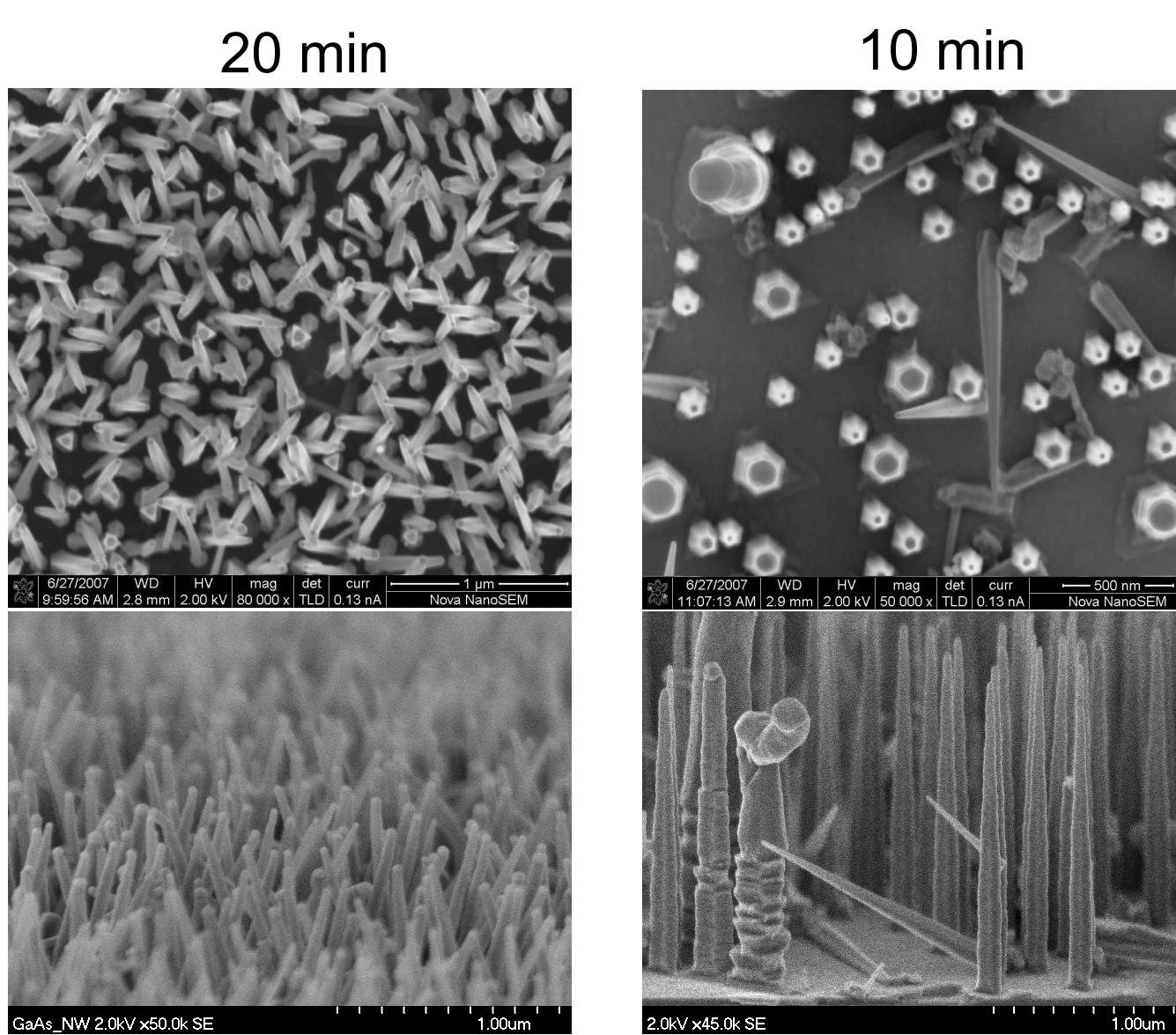


Oriented Growth of GaAs Nanowires on (111)As substrates

- Performed growth on (111)As utilizing coalesced Au films following previous recipe
- Nanowires start growth normal to (111)As surface
 - Shows that growth proceeds by 60° rotation of crystal planes
 - Suggests that nanowires are wurzite (hexagonal) instead of zinc blende (cubic)
 - Form kinks that allow propagation in other directions



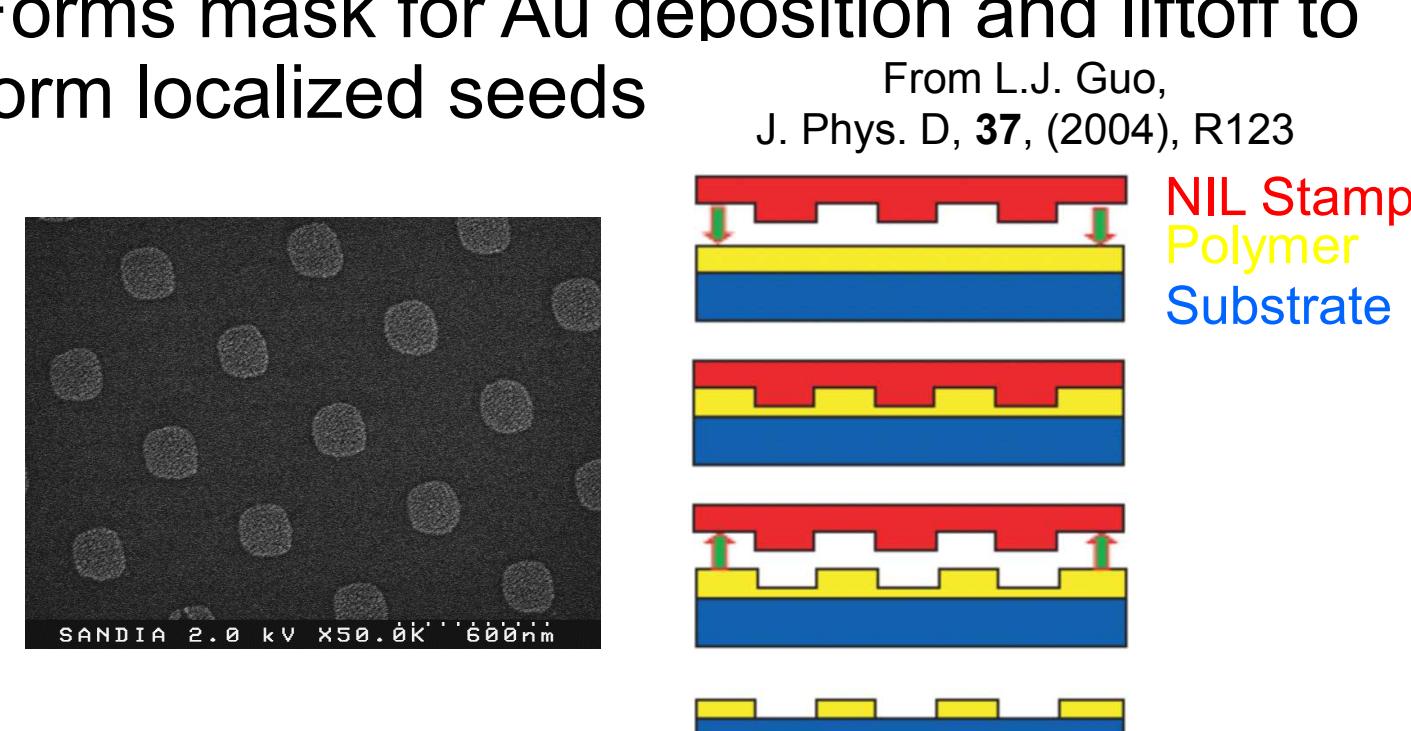
Nanowire kinking determined by length



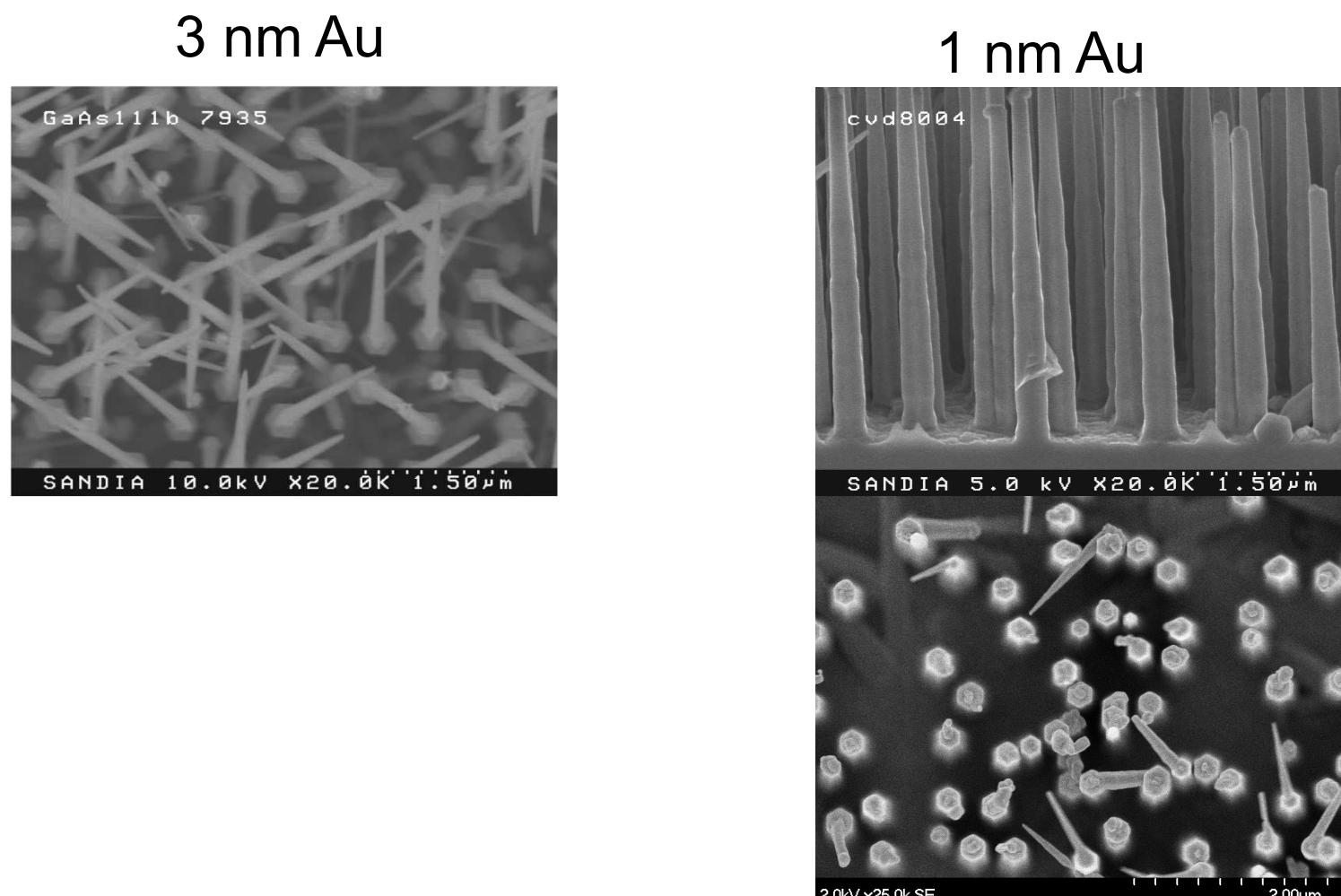
Nano-Imprint Lithography (NIL)

a route to controlled nanowire size and placement

- NIL allows periodic features to be generated
- Forms mask for Au deposition and lift-off to form localized seeds



NIL seeded nanowires



Doping issues with VLS/VSS Nanowires

- Devices require independent control of Fermi level
 - Accomplished through doping
- Temperatures used for VLS/VSS growth is dominated by background impurities
 - Carbon is primary background impurity in MOCVD at low growth temperatures
 - Exacerbated due to incomplete decomposition of metal-organics
- Perform SIMS analysis on planar films due to difficulties doing chemical analysis on nanowires

Background impurities in III-V films

- Planar GaAs grown at 450°C is dominated by intrinsic carbon background
 - $1\text{E}19 \text{ cm}^{-3}$
- PL doesn't show bandgap reduction expected for heavily p-type GaAs
- Suggests that GaAs nanowires are compensated ($N_a = N_d$)
 - Carbon acting like both donor and acceptor
 - SEM images of nanowires show charging effects at high magnifications
- Slightly higher growth temperature (500°C) removes compensation allows planar films to be doped n-type at $5\text{E}17 \text{ cm}^{-3}$ with Si.
- Planar InP grown at 450°C shows also shows carbon concentration $\sim 4\text{E}17 \text{ cm}^{-3}$
- TMI decomposes more efficiently at low temperatures
- Carbon is probably a donor in InP
- Speculate* that InAs will have similar background doping level
 - Carbon is a donor in InAs
- Charging of InAs and InP nanowires not an issue

Conclusions

- (In,Ga)-(As,P) nanowires can be synthesized by MOCVD using VLS/VSS technique
- Tapering and faceting of GaAs nanowires depends on arsine partial pressure and growth temperature
- Growth on (111)As substrates results in preferential growth of orthogonal nanowires
- NIL seed formation on (111)As substrates is a route to control of nanowire orientation, placement, and size
- Controlled doping of GaAs nanowires is a challenge due to high background carbon levels
- Doping of InP and InAs nanowires appears easier